

EAST Search History

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|---|---|------------------|---------|---------------------|
| L3 | 312 | semiconductor and coolant and channel\$1 and microstructure | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/05/11 09:32 |
| L4 | 1804 | 372/34.ccls. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/05/11 09:33 |
| L5 | 193 | L4 and semiconductor near3 laser and channel\$1 | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/05/11 09:33 |
| L6 | 5 | ((("7000684") or ("5783316")).PN. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2009/05/11 10:05 |
| L7 | 1804 | 372/34.ccls. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/05/11 10:12 |
| L8 | 612 | 372/35.ccls. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/05/11 10:53 |
| L9 | 1348 | 372/36.ccls. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/05/11 11:14 |
| L10 | 1467 | 372/50.1.ccls. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/05/11 12:28 |
| L11 | 123 | thermal near3 conductivity near3 molybdenum with copper | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/05/11 13:12 |

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|-----|------|---|---|----|-----|---------------------|
| L12 | 62 | (high near3 modulus near3 elasticity and (diamond near3 (copper or cobalt or aluminum))) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/05/11 13:17 |
| L13 | 55 | (stefan near3 groetsch). in. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/05/11 13:19 |
| L14 | 19 | (semiconductor and cool \$4 and channel and thermal and expan\$4 and heat and transfer).dm. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/05/11 13:23 |
| S1 | 6 | ((("5105430") or ("5373731") or ("5812570") or ("5903583") or ("20020063329") or ("20030099267")).PN. | US-PGPUB; USPAT | OR | OFF | 2007/06/24 11:01 |
| S2 | 1040 | thermal near3 conductivity with molybdenum | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2007/06/24 11:02 |
| S3 | 104 | thermal near3 conductivity near3 molybdenum with copper | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2007/06/24 11:03 |
| S4 | 12 | ((thermal near3 conductivity near3 molybdenum) with copper) and "372"/\$.ccls. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2007/06/24 12:11 |
| S5 | 10 | ((high near3 modulus near3 elasticity near3 molybdenum)) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2007/06/24 11:55 |
| S6 | 0 | (high near3 modulus near3 elasticity near3 (diamond near3 (copper or cobalt or aluminum))) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2007/06/24 11:56 |
| S7 | 0 | (high near3 modulus near3 elasticity with (diamond near3 (copper or cobalt or aluminum))) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2007/06/24 11:56 |

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| S8 | 0 | (high near3 modulus near3 elasticity same (diamond near3 (copper or cobalt or aluminum))) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2007/06/24 11:57 |
| S9 | 0 | (modulus near3 elasticity near3 (diamond near3 (copper or cobalt or aluminum))) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2007/06/24 11:56 |
| S10 | 40 | (high near3 modulus near3 elasticity and (diamond near3 (copper or cobalt or aluminum))) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2007/06/24 11:57 |
| S11 | 33 | ((thermal near3 conductivity near3 diamond) with copper) and "372"/\$.ccls. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2007/06/24 12:12 |
| S12 | 11 | ((diamond near3 composite) with (electrical near3 conductivity)) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2008/02/06 16:03 |
| S13 | 1 | ((diamond near3 cobalt) with (electrical near3 conductivity)) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2008/02/06 16:07 |
| S14 | 1 | ((diamond near3 cobalt) same (electrical near3 conductivity)) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2008/02/06 16:08 |
| S15 | 5 | ((diamond with cobalt) with (electrical near3 conductivity)) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2008/02/06 16:08 |
| S16 | 1 | ((diamond near3 cobalt) with (electrical)) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2008/02/06 16:28 |
| S17 | 3 | ((diamond near3 cobalt) with (conductivity)) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2008/02/06 16:29 |

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| S18 | 36 | ((diamond near3 cobalt near3 composite)) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2008/02/06 16:30 |
| S19 | 0 | ((polycrystalline near3 diamond) with (electrical near3 conductivity)) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2008/02/06 16:34 |
| S20 | 0 | ((polycrystalline near3 diamond) with (electrical near3 conductivity)) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2008/02/06 16:35 |
| S21 | 0 | ((pcd) with (electrical near3 conductivity)) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2008/02/06 16:35 |
| S22 | 610 | 372/35.ccls. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/05 12:44 |
| S23 | 120 | S22 and semiconductor near3 laser | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/05 12:45 |
| S24 | 2255 | semiconductor and cool\$4 and channel and microstructure | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/05 13:11 |
| S25 | 301 | semiconductor and coolant and channel\$1 and microstructure | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/05 13:11 |
| S26 | 299 | S25 not S23 | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/05 13:11 |
| S27 | 490 | S22 not S23 | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/05 13:45 |

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| S28 | 1784 | 372/34.ccls. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/05 14:21 |
| S29 | 50 | S28 and semiconductor near3 laser and coolant | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/05 14:22 |
| S30 | 187 | S28 and semiconductor near3 laser and channel\$1 | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/05 14:27 |
| S31 | 155 | S30 not S29 | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/05 14:27 |
| S32 | 1597 | S28 not S30 | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/05 14:33 |
| S33 | 1333 | 372/36.ccls. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/05 15:34 |
| S34 | 78 | S33 and semiconductor near3 laser and coolant | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/05 15:34 |
| S35 | 53 | S34 not S29 | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/05 15:35 |
| S36 | 1450 | 372/50.1.ccls. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/09 10:27 |
| S37 | 7 | S36 and semiconductor near3 laser and coolant | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT | OR | ON | 2009/03/09 10:27 |

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